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TC 2800 MAIL ROOM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

10/A

7-10-01

T. Flowers

In re Application of:

Ma, et al.

Serial No.: 09/374,502

Filed: August 13, 1999

For: ISOLATION STRUCTURE
CONFIGURATIONS FOR
MODIFYING STRESSES IN
SEMICONDUCTOR DEVICES

Examiner: J. Fenty

Group Art Unit: 2815

Attorney Docket No.: 42390.P6623

CERTIFICATE OF MAILING

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AMENDMENT

Hon. Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action mailed February 20, 2001 with the term for response having been extended by one month, Applicants respectfully request that the Examiner enter the following amendments and consider the following remarks: